



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

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In Re U.S. Patent Application

) Art Unit: 1765

Applicant: Kozo Nakamura

) Confirmation No.: 6736

Serial No.: 09/856,209

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Filed: May 18, 2001

For: **SILICON CRYSTAL AND
PRODUCTION METHOD FOR
SILICON SINGLE CRYSTAL
WAFER**

Examiner: Matthew J. Song

Gerald T. Shekleton Reg. No. 27,466

#13E
8/18/03
mw

AMENDMENT

MAIL STOP RCE
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Advisory Action of June 26, 2003 has been carefully reviewed in conjunction with the previous Office Action of March 4, 2003 and the following amendments and remarks are made in response thereto.

A Petition for Extension of Time Under 37 CFR 1.136(a) is enclosed.